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Substitute for Form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

1

of

1

Complete if Known

Application Number

09/938,411

Filing Date

August 23, 2001

First Named Inventor

Wan-Thai, Hsu, et al.

Group Art Unit

2834

Examiner Name _____

T. D. Macdonald

Attorney Docket Number

UOM 0210 BUSP

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

Examiner
Signature

Thomas M. Cougherty

Date _____

Considered

11-14-02

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST 3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.



Substitute for Form 1449B/PTO			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	09/938,411	
			Filing Date	August 23, 2001	
			First Named Inventor	Wan-Thai Hsu et al.	
			Group Art Unit	2834	
			Examiner Name	Unknown <i>T. Dougherty</i>	
Sheet	1	of	1	Attorney Docket Number	UOM 0210 PUSP / 1899

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
<i>TMD</i>		C. T.-C. NGUYEN, "Micromachining technologies for miniaturized communication devices," Proceedings of SPIE: Micromachining and Microfabrication, Sept. 20-22, 1998, pgs. 24-38	
<i>TMD</i>		T. HIRANO et al., "Design, Fabrication, and Operation of Submicron Gap Comb-Drive Microactuators," Journal of Microelectromechanical Systems, March 1992, No. 1, pgs. 52-59	
<i>TMD</i>		J.R. TUCKER et al., "Nanoscale FETs and STM Lithography," University of Illinois, 1995, pgs. 425-434 <i>8/95</i>	<input checked="" type="checkbox"/>
<i>TMD</i>		C. T.-C. Nguyen, "High-Q Micromechanical Oscillators and Filters For Communications," Int'l Symposium on Circuits and Systems, June 9-12, 1997, pgs. 2825-2828	<input checked="" type="checkbox"/>
<i>TMD</i>		K. TANAKA, "Nanotechnology towards the 21 st Century," Thin Solid Films, 1999, pgs. 120-125 <i>12/99</i>	

Examiner Signature	<i>Thomas M. Dougherty</i>	Date Considered	<i>11-14-02</i>
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